



Docket No.: 205975US2

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COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 09/832,892

Applicants: Takehisa YAMAGUCHI, et al.

RCE Filed: November 2, 2003

For: LIQUID CRYSTAL DISPLAY AND
MANUFACTURING METHOD THEREFOR

Group Art Unit: 2871

Examiner: Nguyen, H.C.

SIR:

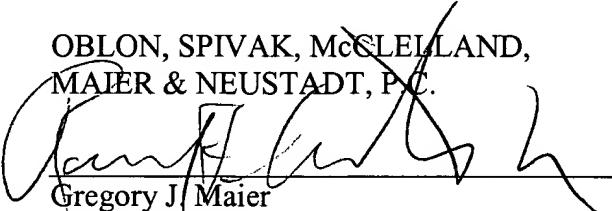
Attached hereto for filing are the following papers:

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Our check in the amount of - 0 - is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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205975US-2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF : DATE ALLOWED: 05/12/04
TAKEHISA YAMAGUCHI, ET AL. : GROUP ART UNIT: 2871
SERIAL NO: 09/832,892 :
RCE FILED: NOVEMBER 2, 2003 : EXAMINER: NGUYEN, H.C.
FOR: LIQUID CRYSTAL DISPLAY :
AND MANUFACTURING
METHOD THEREFOR

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

The Examiner's statement of "REASONS FOR ALLOWANCE" included on page 2 attached to the "Notice of Allowability" (PTOL-37) that is in turn attached to the "Notice of Allowance and Fee(s) Due" mailed May 12, 2004, is mistaken in referring to previously withdrawn independent Claims 11 and 12 as containing the exact same subject matter as independent Claim 1 in terms of "a near side facing in parallel with the source electrode and being superposed with said gate electrode;" and "a far side opposed to and in parallel with the near side and not being superposed with the gate electrode."

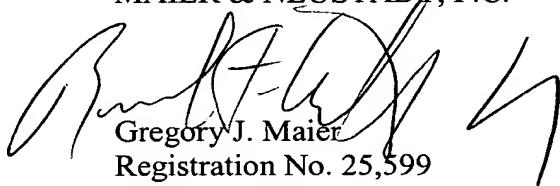
Instead of the "in parallel" language of Independent Claim 1, previously withdrawn independent Claim 11 recites "that two drain electrode portions are formed with a near side opposed to said source electrode that is superposed in a channel lengthwise direction with said gate electrode line and with a far side opposite to the near side in the channel lengthwise direction that is not superposed with said gate

electrode line.” Similarly, previously withdrawn method Claim 12 recites slightly different subject matter as to a step of “subjecting said deposited conductive film to patterning in such a manner that two drain electrodes are formed extending in a channel lengthwise direction with near sides and opposite facing far sides, with only the near sides being superposed with a gate electrode, said drain electrode lines being opposed to said source electrode at both near sides.”

In addition, it is noted that the above-noted “Reasons for Allowance” contain a further error in terms of reciting that “Claims 2-10 and 113 are allowed” instead of reciting that --Claims 2-10 and 13 are allowed--.

Respectfully submitted,

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